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Class	Subclass

PATENT NUMBER

U.S. **UTILITY** Patent Application

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APPLICATION NO. 09/774723	CONT/PRIOR F	CLASS 356	SUBCLASS 237 2	ART UNIT 2877	EXAMINER Diane Lee Rosenberger
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APPLICANTS

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TITLE

Polishing pad surface condition evaluation method and an apparatus thereof and a method of producing a semiconductor device

PTO-2040
12/89[illegible]

<input type="checkbox"/> TERMINAL DISCLAIMER	DRAWINGS			CLAIMS ALLOWED	
	Sheets Drwg.	Figs. Drwg.	Print Fig.	Total Claims	Print Claim for O.G.
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